

# **3D Packaging and Integration Global Technical Committee**

# Japan TC Chapter

# **Meeting Summary and Minutes**

Japan Standards Winter 2022 Meetings in conjunction with SEMICON Japan 2022

December 14, 2022, 10:00-12:00[JST]

Conference Tower, Tokyo Big sight, Tokyo, Japan/OVTCCM(Hybrid)

# **TC Chapter Announcements**

*Next TC Chapter Meeting* Wednesday, March 15, 2023, 13:30-15:30 OVTCCM

# **Table 1 Meeting Attendees**

Italics indicate virtual participants

# **Co-Chairs:** Kazunori Kato (AiT), Masahiro Tsuriya (iNEMI), Haruo Shimamoto (AIST) **SEMI Staff:** Mami Nakajo

Company	Last	First	Company	Last	First
AIST	Shimamoto	Haruo	Namics Corporation	Okoshi	Kodai
AiT	Kato	Kazunori	Namics Corporation	Kamimura	Tsuyoshi
iNEMI	Tsuriya	Masahiro	Hitachi Power Solutions Co.,Ltd.	Ohno	Shigeru
Nidec-Read Corp.	Miyasaka	Takashi	retired	Takahashi	Mark
Towa Corporation	Onishi	Yohei	SEMI Japan	Nakajo	Mami

# Table 2 Leadership Changes

WG/TF/SC/TC Name	Previous Leader	New Leader
None		

#### Table 3

Previous WG/TF/SC Name	New WG/TF/SC Name or Status Change
None	

#### Table 4

None

#### **Table 5 Ballot Results**

None



# Table 6 Activities Approved by the GCS between meetings of the TC Chapter

#	Type	SC/TF/WG	Details
TBD	SNARF	3D Packaging & Integration 5-Year Review TF	Reapproval of G89-0211 (Reapproved 0318) Specification for Leadframe Strip Size
TBD	SNARF	3D Packaging & Integration 5-Year Review TF	Reapproval of SEMI G71-0996 (Reapproved 0318): Specification for Barcode Marking of Intermediate Containers for Packaging Materials
TBD	SNARF	3D Packaging & Integration 5-Year Review TF	Reapproval of SEMI G69-0996 (Reapproved 0318): Test Method for Measurement of Adhesive Strength Between Leadframes and Molding Compounds
TBD	SNARF	3D Packaging & Integration 5-Year Review TF	Reapproval of SEMI G90-0811 (Reapproved 0318): Specification for 300 mm Wafer Coin-Stack Type Shipping Container Used for Test and Packaging Processes
TBD	SNARF	3D Packaging & Integration 5-Year Review TF	Reapproval of SEMI G66-96 (Reapproved 0318):Test Method for the Measurement of Water Absorption Characteristics for Semiconductor Plastic
TBD	SNARF	3D Packaging & Integration 5-Year Review TF	Reapproval of SEMI G23-0996 (Reapproved 0318): Test Method of Inductance for Internal Traces of Semiconductor Packages

# **Table 7 Authorized Activities**

#	When	SC/TF/WG	Details
TBD	Cycle 2-2023	3D Packaging & Integration 5- Year Review TF	Reapproval of G89-0211 (Reapproved 0318) Specification for Leadframe Strip Size
TBD	Cycle 2-2023	00	Reapproval of SEMI G71-0996 (Reapproved 0318): Specification for Barcode Marking of Intermediate Containers for Packaging Materials
TBD	Cycle 2-2023	00	Reapproval of SEMI G69-0996 (Reapproved 0318): Test Method for Measurement of Adhesive Strength Between Leadframes and Molding Compounds
TBD	Cycle 2-2023	00	Reapproval of SEMI G90-0811 (Reapproved 0318): Specification for 300 mm Wafer Coin-Stack Type Shipping Container Used for Test and Packaging Processes
TBD	Cycle 2-2023		Reapproval of SEMI G66-96 (Reapproved 0318):Test Method for the Measurement of Water Absorption Characteristics for Semiconductor Plastic
TBD	Cycle 2-2023	00	Reapproval of SEMI G23-0996 (Reapproved 0318): Test Method of Inductance for Internal Traces of Semiconductor Packages

#### **Table 8 Authorized Ballots**

#	When	TF	Details
None			

# Table 9 SNARF(s) Granted a One-Year Extension

None



#### Table 10 SNARF(s) Abolished

None

#### Table 11 Standard(s) to receive Inactive Status

Standard Designation	Title
None	

#### Table 12 New Action Items

Item #	Assigned to	Details
	00	To confirm documents and prepare SNARFs for these Reapproval Documents on the list by the next TC meeting.

#### **Table 13 Previous Meeting Action Items**

Item #	Assigned to	Details
20220516-01	3D Packaging & Integration 5 Year Review Task Force	To prepare SNARFs for these Reapproval Documents by the next TC meeting.>Done
20220516-02	3D Packaging & Integration Steering Group	to consider whether 3D Packaging & Integration Steering Group will be Inactive Status or discharged by the next TC meeting.>Open

#### 1.Welcome, Reminders, and Introductions

Haruo Shimamoto (AIST) called the meeting to order at 10:00 a.m. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed. Attendees introduced themselves.

Attachment: 01-02\_Required Element Nov 2022\_E+J (new template)

#### 2.Review of Previous Meeting Minutes

The TC Chapter reviewed the minutes of the previous meeting.

Motion:	Approve the previous meeting minutes of the I&C Japan TC Chapter on January 13, 2022.	
By / 2 <sup>nd</sup> :	Haruo Shimamoto (AIST) / Mark Takahashi (retired)	
Discussion:	None	
Vote:	7 in favor and 0 opposed. Motion passed.	

Attachment: 02-01\_20220516\_3DPI-Japan\_MeetingMinutes\_approved

# **3.Technical Committee Awards**

For the 7 new Standards were published on November 2022, the following member received the awards for contributions to the "Encapsulation Characteristics for WLP&PLP Taskforce activities

3

Masahiro Tsuriya iNEMI



- · Hidetoshi Arai APIC YAMADA CORPORATION
- Haruo Shimamoto
  The National Institute of Advanced Industrial Science and Technology
- Tsuyoshi Kamimura NAMICS Corporation
- · Kodai Okoshi NAMICS Corporation
- Takashi Miyasaka NIDEC READ CORPORATION
- Takakage Matsumoto Panasonic Industry Co., Ltd.
- Hirofumi Kuroda Sumitomo Bakelite Co., Ltd.
- · Yohei Oonishi TOWA CORPORATION
- Tetsuya Yamada TOWA CORPORATION

#### 4.Liaison Reports

4.1 3D Packaging & Integration North America TC Chapter

Mami Nakajo (SEMI Japan ) reported the 3D Packaging & Integration North America TC Chapter activity status based on the report as attached.

Attachment: 04-01\_NA 3DP&I Liaison Report Nov2022 v1,

# 4.2 3D Packaging & Integration Taiwan TC Chapter

Mami Nakajo (SEMI Japan ) reported the 3D Packaging & Integration Taiwan TC Chapter activity status based on the report as attached.

Attachment: 04-02\_3D P&I TW Liaison Report\_20220411\_V1

# 4.3 SEMI Staff Report

Mami Nakajo (SEMI) explained the SEMI Staff Report based on the report as attached.

Attachment: 04-03\_Staff Report 2022Dec,

# **5.Ballot Review**

None

# 6.Subcommittee and Task Force Reports

6.1 GCS Report

No report

# 6.2 3D Packaging & Integration 5 Year Review Task Force

Masahiro Tsuriya (iNEMI) reported the 3D Packaging & Integration 5 Year Review Task Force status as attached.



# 6.3 3DS IC Bonded Layer Inspection Metrology Task Force

Haruo Shimamoto (AIST) reported the status of 3DS IC Bonded Layer Inspection Metrology Task Force as attached. .

Attachment: 06-03\_ActivitiesReport\_3DSIC-InspectionTF\_20221214\_Submit

# 6.4 Encapsulation Characteristics for Wafer Level Package and Panel Level Packaging Task Force

Masahiro Tsuriya (iNEMI) reported the status of Encapsulation Characteristics for Wafer Level Package and Panel Level Packaging Task Force as attached.

Attachment: 06-04\_TF Report 1.3 - PLP Encapsulation Characterisitc TF v2022\_12

# 6.5 Panel Level Packaging (PLP) Glass Carrier Task Force

Mark Takahashi (retired) reported the status of Panel Level Packaging Glass Carrier Task Force as attached.

Attachment: 06-05\_PLP Glass Carrier TF Status\_20221214

# 6.6 3D Packaging & Integration Steering Group

Masahiro Tsuriya (iNEMI) proposed to decide the direction of future activities by the next committee meeting.

Action Item: 20220516-02 (3D Packaging & Integration Steering Group) To consider whether 3D Packaging & Integration Steering Group will be Inactive Status or discharged by the next TC meeting.>Open

# 7 Old Business

7.1 SNARF Project Period Check

There are no SNARFs to be reviewed.

# 7.2 5 Years Review Check

Action Item: 20221214-01 (3D Packaging & Integration 5 Year Review TF) To confirm documents and prepare SNARFs for these Reapproval Documents by the next TC meeting.

- SEMI G94-EN : SEMI G94-0113 (Reapproved 1118)-EN
- SEMI G64-EN : SEMI G64-1118-EN

# 8 New Business

8.1 Proposal of New Activity

8.1.1 SNARF Proposal for Reapproval of SEMI G89-0211 (Reapproved 0318) Specification for Leadframe Strip Size

Motion:	Approve the SNARF for Reapproval of SEMI G89-0211 (Reapproved 0318) Specification for Leadframe Strip Size
By / 2 <sup>nd</sup> :	Kazunori Kato (Advanced Interface Technology Corp.) / Mark Takahashi (retired)
Discussion:	None
Vote:	7 in favor and 0 opposed. Motion Passed.

Attachment: SNARF\_G89\_Reapproval\_r1



8.1.2 SNARF Proposal for Reapproval of SEMI G71-0996 (Reapproved 0318) Specification for Barcode Marking of Intermediate Containers for Packaging Materials

Motion:	Approve the SNARF for Reapproval of SEMI G71-0996 (Reapproved 0318) Specification for Barcode Marking of Intermediate Containers for Packaging Materials
By / 2 <sup>nd</sup> :	Masahiro Tsuriya (iNemI) / Mark Takahashi (retired)
Discussion:	None
Vote:	7 in favor and 0 opposed. Motion Passed.

#### Attachment: SNARF\_G71\_Reapproval\_r1

8.1.3 SNARF Proposal for Reapproval of SEMI G69-0996 (Reapproved 0318) Test Method for Measurement of Adhesive Strength Between Leadframes and Molding Compounds

Motion:	Approve the SNARF for Reapproval of SEMI G69-0996 (Reapproved 0318) Test Method for Measurement of Adhesive Strength Between Leadframes and Molding Compounds	
By / 2 <sup>nd</sup> :	Aasahiro Tsuriya (iNemI) / Mark Takahashi (retired)	
Discussion:	None	
Vote:	7 in favor and 0 opposed. Motion Passed.	

**Attachment:** SNARF\_G69\_Reapproval\_r2

8.1.4 SNARF Proposal for Reapproval of SEMI G90-0811 (Reapproved 0318) Specification for 300 mm Wafer Coin-Stack Type Shipping Container Used for Test and Packaging Processes

Motion:	Approve the SNARF for Reapproval of SEMI G90-0811 (Reapproved 0318) Specification for 300 mm Wafer Coin-Stack Type Shipping Container Used for Test and Packaging Processes	
By / 2 <sup>nd</sup> :	Kazunori Kato (Advanced Interface Technology Corp. ) / Mark Takahashi (retired)	
Discussion:	None	
Vote:	8 in favor and 0 opposed. Motion Passed.	

Attachment: SNARF\_G90\_Reapproval\_r1

8.1.5 SNARF Proposal for Reapproval of SEMI G66-96 (Reapproved 0318) Test Method for the Measurement of Water Absorption Characteristics for Semiconductor Plastic Molding Compounds

Motion:	Approve the SNARF for Reapproval of SEMI G66-96 (Reapproved 0318) Test Method for the Measurement of Water Absorption Characteristics for Semiconductor Plastic Molding Compounds	
By / 2 <sup>nd</sup> :	Masahiro Tsuriya (iNemI) / Mark Takahashi (retired)	
Discussion:	None	
Vote:	8 in favor and 0 opposed. Motion Passed.	

# **Attachment:** SNARF\_G66\_Reapproval\_r2

8.1.6 SNARF Proposal for Reapproval of SEMI G23-0996 (Reapproved 0318) Test Method of Inductance for Internal Traces of Semiconductor Packages

Motion:	Approve the SNARF for Reapproval of SEMI G23-0996 (Reapproved 0318) Test Method of Inductance for Internal Traces of Semiconductor Packages	
By / 2 <sup>nd</sup> :	Kazunori Kato (Advanced Interface Technology Corp. ) / Mark Takahashi (retired)	
Discussion:	None	
Vote:	8 in favor and 0 opposed. Motion Passed.	

**Attachment:** SNARF\_G23\_Reapproval\_r2

8.1.7 Approval request for ballot issuance of Reapproval of the following documents in Cycle 2/2023 by 3D Packaging & Integration 5 Year Review Task Force



SEMI G89-0211 (Reapproved 0318) Specification for Leadframe Strip Size

SEMI G71-0996 (Reapproved 0318) Specification for Barcode Marking of Intermediate Containers for Packaging Materials

SEMI G69-0996 (Reapproved 0318) Test Method for Measurement of Adhesive Strength Between Leadframes and Molding Compounds

SEMI G90-0811 (Reapproved 0318) Specification for 300 mm Wafer Coin-Stack Type Shipping Container Used for Test and Packaging Processes

SEMI G66-96 (Reapproved 0318) Test Method for the Measurement of Water Absorption Characteristics for Semiconductor Plastic Molding Compounds

SEMI G23-0996 (Reapproved 0318) Test Method of Inductance for Internal Traces of Semiconductor Packages

Motion:	Authorize the following Documents for Letter Ballots in Cycle2/2023 by 3D Packaging & Integration 5 Year Review Task Force	
	SEMI G89-0211 (Reapproved 0318) Specification for Leadframe Strip Size	
	SEMI G71-0996 (Reapproved 0318) Specification for Barcode Marking of Intermediate Containers for Packaging Materials	
	SEMI G69-0996 (Reapproved 0318) Test Method for Measurement of Adhesive Strength Between Leadframes and Molding Compounds	
	SEMI G90-0811 (Reapproved 0318) Specification for 300 mm Wafer Coin-Stack Type Shipping Container Used for Test and Packaging Processes	
	SEMI G66-96 (Reapproved 0318) Test Method for the Measurement of Water Absorption Characteristics for Semiconductor Plastic Molding Compounds	
	SEMI G23-0996 (Reapproved 0318) Test Method of Inductance for Internal Traces of Semiconductor Packages	
By / 2 <sup>nd</sup> :	Masahiro Tsuriya ( iNemI) /Kazunori Kato (Advanced Interface Technology Corp. )	
Discussion:	None	
Vote:	8 in favor and 0 opposed. Motion Passed.	

# 9 Action Item Review

#### 9.10pen Action Items

Item #	Assigned to	Details
20220516-01	6666	To prepare SNARFs for these Reapproval Documents by the next TC meeting.>Done
20220516-02	3D Packaging & Integration Steering Group	to consider whether 3D Packaging & Integration Steering Group will be Inactive Status or discharged by the next TC meeting.>Open

#### 9.2New Action Items

The TC Chapter reviewed the following new action item.

Item #	Assigned to	Details
20221214-01	3D Packaging & Integration 5 Year Review Task Force	To confirm documents and prepare SNARFs for these Reapproval Documents on the list by the next TC meeting.



#### Next Meeting and Adjournment

The next meeting is scheduled for Wednesday, March 15,2023,13:30-15:30[JST] OVTCCM See <u>http://www.semi.org/standards-events</u> for the current list of events.

Having no further business, a motion was made to adjourn. Adjournment was at 12:30.

Respectfully submitted by: Mami Nakajo Coordinator SEMI Japan Phone: +81.3.3222.5949 Email: mnakajo@semi.org

#### Minutes tentatively approved by:

Kazunori Kato (AiT), Co-chair	December 19, 2022
Masahiro Tsuriya (iNEMI), Co-chair	December 20, 2022
Haruo Shimamoto (ASIT), Co-chair	December 19, 2022

#### Table 14 Index of Available Attachments#1

Title	Title
01-02_Required Element Nov 2022_E+J (new template)	SNARF_G89_Reapproval_r1
02-01_20220516_3DPI-Japan_MeetingMinutes_approved	SNARF_G71_Reapproval_r1
04-01_NA 3DP&I Liaison Report Nov2022 v1,	SNARF_G69_Reapproval_r2
04-02_3D P&I TW Liaison Report_20220411_V1	SNARF_G90_Reapproval_r1
04-03_Staff Report 2022Dec,	SNARF_G66_Reapproval_r2
06-02_TF Report 1.1 - 5yrs Review TF v2022_12	SNARF_G23_Reapproval_r2
06-03_ActivitiesReport_3DSIC- InspectionTF_20221214_Submit	
06-04_TF Report 1.3 - PLP Encapsulation Characterisitc TF v2022_12	
06-05_PLP Glass Carrier TF Status_20221214	

#1 Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact [SEMI Staff Name] at the contact information above.